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**(54) Organic light emitting display having an electrostatic discharge circuit**

Organische lichtemittierende Anzeigevorrichtung mit elektrostatischer Entladungsschaltung  
 Dispositif d'affichage électroluminescent organique doté d'un circuit de décharge électrostatique

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**Description**

## BACKGROUND

Field of the Invention

**[0001]** The invention relates to an organic light emitting display, and more particularly, to an organic light emitting display that can prevent a pixel and a driver included in the organic light emitting display from being damaged due to electrostatic discharge.

Description of the Related Technology

**[0002]** An organic light emitting display is a kind of flat panel display and uses an organic light emitting diode (OLED) which emits light by recombination of electrons supplied from a cathode with holes supplied from an anode. The organic light emitting display has advantageous aspects of being thin, having a wide viewing angle, and having a short response time.

**[0003]** Methods for driving the organic light emitting display include a passive matrix method and an active matrix method. The passive matrix method is a method that selects and drives a line where an anode and a cathode intersect at right angles. On the other hand, the active matrix method is a method that realizes an image by supplying an organic light emitting diode (OLED) with a driving current corresponding to a data signal. The organic light emitting diode (OLED) uses a thin film transistor (TFT) formed on each pixel. The active matrix method has an advantageous aspect that it can exhibit more stable brightness and can consume less power than the passive matrix method, and thus it can be applied to large and high-resolution displays.

**[0004]** A conventional organic light emitting display comprises a pixel area including a pixel matrix and a non-pixel area including a power supply and a driver for driving the plurality of pixels. The pixels are located in the pixel area and each pixel includes a thin film transistor and an organic light emitting diode for a driving operation or a switching operation. The pixel area and the non-pixel area are electrically coupled with each other through a plurality of lines.

**[0005]** The conventional organic light emitting display is manufactured by forming a thin film transistor, forming an organic light emitting diode, encapsulating, and packaging. During such manufacturing steps, static electricity can be generated in the organic light emitting display by internal environmental factors or by external environmental factors. The static electricity can be generated during nearly all manufacturing processes for manufacturing the organic light emitting display including a deposition process, an etching process, etc. Furthermore, the static electricity can also be generated by an external environmental factor during displaying an image on the organic light emitting display.

**[0006]** According to the conventional light emitting dis-

play, a problem is that an internal circuit is damaged due to electrostatic discharge (ESD) that occurs during the above-mentioned or other manufacturing steps or by an external environmental factor.

5 **[0007]** US 2005/186715 A1, US-A-5 824 235, US 2005/078232 A1, US-A-5 220 443, WO 97/10529 A and US 2005/023614 A1 disclose ESD-protection devices in displays.

## 10 SUMMARY OF CERTAIN INVENTIVE ASPECTS

**[0008]** The aforementioned problems of the conventional organic light emitting display can be solved with the organic light emitting display of claim 1, which defines the present invention. Further advantages are defined in the dependent claims.

15 Preferably the electrostatic discharge circuit further comprises a semiconductor layer formed between the substrate and the first electrode layer. Preferably the electrostatic discharge circuit further comprises a second insulating layer formed between the semiconductor layer and the first electrode layer. Preferably the electrostatic discharge circuit further comprises a buffer layer formed between the substrate and the semiconductor layer.

20 Preferably the electrostatic discharge circuit further comprises a protective layer formed on the second electrode layer. Preferably the electrostatic discharge circuit further comprises a third electrode layer formed on the protective layer and is electrically coupled with the second electrode layer through a via hole.

25 Preferably the non-pixel area further comprises: at least one driver configured to drive a pixel in the pixel area; and a pad configured to electrically couple the pixel and the driver with an external module. Preferably the pad is formed on at least one side of the inner circumference of the substrate. Preferably the electrostatic discharge circuit is formed on at least one side of the inner circumference of the substrate other than a side on which the pad is formed.

30 Preferably the electrostatic discharge circuit is separately formed on each side of the inner circumference of the substrate. Alternatively, the electrostatic discharge circuit is integrally formed to substantially surround the inner circumference of the substrate. Preferably any of the first electrode layer and the second electrode layer is electrically coupled with a ground pad. Preferably the first electrode layer and the second electrode layer comprises at least one of aluminum, aluminum-neodymium, chrome, molybdenum, molybdenum-tungsten and titanium. Preferably the first insulating layer comprises at least one of silicon oxide, silicon nitride and an organic matter.

35 Furthermore, the pad and drivers (such as data driver, scan driver and emission control driver) are preferably located completely within the non-pixel area.

40 The expression electrostatic discharge circuit does not necessarily mean that conductive lines are formed as a closed loop, however, the expression electrostatic discharge circuit means that at least two conductive layers

are arranged such that a breakdown of an insulating layer therebetween can be induced (or controlled) and therefore static electricity can be discharged.

**[0009]** An additional aspect is an organic light emitting display including a substrate including a pixel area and a non-pixel area, and an electrostatic discharge circuit in the non-pixel area, the electrostatic discharge circuit including a semiconductor layer formed on the substrate, a gate insulating layer formed on the semiconductor layer, a gate electrode formed on the gate insulating layer, an insulating interlayer formed to cover the gate electrode, and a source/drain electrode formed on the insulating interlayer, where the gate electrode includes a first protruding electrode formed to extend horizontally toward the source/drain electrode.

Preferably the source/drain electrode comprises a second protruding electrode formed to extend horizontally toward the gate electrode. Preferably the first protruding electrode and the second protruding electrode are formed in the shape of any of a saw-tooth, a triangle, a rectangle, a pentagon and a trapezoid. Preferably the electrostatic discharge circuit is formed such that the first protruding electrode and the second protruding electrode extend toward one another.

Preferably at least one of the gate electrode and the source/drain electrode is electrically coupled with a ground pad. Preferably the electrostatic discharge circuit further comprises a buffer layer formed between the substrate and the semiconductor layer. Preferably the electrostatic discharge circuit further comprises a protective layer formed on the source/drain electrode. Preferably the electrostatic discharge circuit further comprises an electrode layer formed on the protective layer and is electrically coupled with the source/drain electrode.

#### BRIEF DESCRIPTION OF THE DRAWINGS

**[0010]** The above and other objects, features and advantages will be more apparent from the following detailed description taken in conjunction with the accompanying drawings, in which:

**[0011]** FIG. 1 is a schematic view showing an organic light emitting display according to an embodiment;

**[0012]** FIG. 2 is a plan view showing "A" portion of FIG. 1;

**[0013]** FIG. 3 is a vertical cross-sectional view taken along the line I-I of FIG. 2;

**[0014]** FIG. 4 is a plan view showing a portion, which corresponds to FIG. 2, of another example of an electrostatic discharge circuit;

**[0015]** FIG. 5 is a view showing other shapes of protruding electrodes of FIG. 4;

**[0016]** FIG. 6 is a plan view showing a portion, which corresponds to FIG. 2, of an organic light emitting display according to another embodiment;

**[0017]** FIG. 7 is a vertical cross-sectional view taken along the line II-II of FIG. 6; and

**[0018]** FIG. 8 is a schematic view showing an organic

light emitting display according to another embodiment.

#### DETAILED DESCRIPTION CERTAIN INVENTIVE EMBODIMENTS

**[0019]** Hereinafter, certain embodiments will be described with reference to the accompanying drawings. In the drawings, for the purpose of clear explanation, portions that are not related to such an explanation will be sometimes omitted.

**[0020]** An organic light emitting display according to an embodiment will be explained.

**[0021]** FIG. 1 is a schematic view showing an organic light emitting display 100 according to an embodiment.

**[0022]** Referring to FIG. 1, an organic light emitting display 100 according to an embodiment includes: a substrate 110 which includes a pixel area 110a including pixels P arranged in the form of a matrix and a non-pixel area 110b formed on the outer circumference of the pixel area 110a; and an electrostatic discharge circuit 120 formed on the non-pixel area 110b.

**[0023]** The substrate 110 includes the pixel area 110a having approximately a rectangular shape and the non-pixel area 110b formed on the outer circumference of the pixel area 110a. The substrate 110 can be further electrically coupled with a data driver 130, a scan driver 140 and a light emission control driver 150.

**[0024]** The pixel area 110a is an area that displays an image by driving a plurality of pixels arranged in the form of a matrix. Each pixel is formed near an area where a data line (not shown), a scan line (not shown) and a light emission control line (not shown) intersect with each other. Although not shown in FIG. 1, each of the pixels P can include a driving element formed by a thin film transistor, at least one switching element, a capacitive element and an organic light emitting diode.

**[0025]** The non-pixel area 110b is formed on the substrate 110 surrounding the pixel area 110a. In the non-pixel area 110b, the electrostatic discharge circuit 120, the data driver 130 adapted for supplying a data signal for each of the data lines, the scan driver 140 adapted for supplying a scan signal for each of the scan lines and the light emission control driver 150 adapted for supplying a light emission control signal for each of the light emission control lines are preferably formed. Furthermore, the non-pixel area 110b can include a pad 160 for electrically coupling the pixel P, the data driver 130, the scan driver 140 and the light emission control driver 150 with an external module adapted to supply image data and/or video data.

**[0026]** The electrostatic discharge circuit 120 is formed on the non-pixel area 110b of the substrate 110. The electrostatic discharge circuit 120 can be formed to extend along one or more edges of the (preferably rectangular) substrate 110. In this embodiment, the electrostatic discharge circuit 120 is formed on each side of the substrate 110 except a portion where the pad 160 is located. The electrostatic discharge circuit 120 can be

formed as a single piece to surround each side of the substrate 110. The electrostatic discharge circuit 120 protects an inner part, for example, a driving element, a switching element or an organic light emitting diode included in the pixel from being damaged due to electrostatic discharge (ESD) which can occur during a manufacturing process or a subsequent handling process of the organic light emitting display 100. The electrostatic discharge circuit 120 can also protect circuits formed on the non-pixel area 110b such as the data driver 130, the scan driver 140, the light emission control driver 150 and the pad 160 and so on which will be described later. Although the electrostatic discharge circuit 120 has been described as being formed on at least one edge portion of the substrate 110, the invention is not limited thereto. Of course, the electrostatic discharge circuit 120 can be formed on another area of the substrate 110 but preferably only and completely within the non-pixel area 110b. A detailed structure of the electrostatic discharge circuit 120 will be described later.

**[0027]** The data driver 130, the scan driver 140 and the light emission control driver 150 can be placed on the non-pixel area 110b of the substrate 110 as an integrated circuit (IC). The data driver 130, the scan driver 140 and the light emission control driver 150 can be formed on the same layer as the layer forming a thin film transistor (not shown) included in the pixel P of the pixel area 110a. On the other hand, the data driver 130, the scan driver 140 and the light emission control driver 150 can be formed not on the substrate 110 but on another separate substrate. The respective drivers 130, 140 and 150 formed on another separate substrate (not shown) can be electrically coupled with the substrate 110 by any of, for example, a tape carrier package (TCP), a flexible printed circuit (FPC), a tape automated bonding (TAB), a chip on glass (COG) and their equivalents, but is not limited thereto.

**[0028]** The pad 160 is formed on the non-pixel area 110b of the substrate 110. The pad 160 is formed on one side of the substrate 110, and is configured to electrically couple an external circuit module (not shown) with the drivers 130, 140 and 150, or is formed to electrically couple an external circuit module with the pixel P. The electrostatic discharge circuit 120 can be electrically coupled with a ground pad 160a that is formed on at least one side of the pad 160.

**[0029]** The electrostatic discharge circuit 120 that is used for the organic light emitting display 100 according to some embodiments of the present invention will be described in further detail.

**[0030]** FIG. 2 is a plan view showing the "A" portion of FIG. 1, and FIG. 3 is a vertical sectional view of the electrostatic discharge circuit 120 taken along the line I-I of FIG. 2. The electrostatic discharge circuit 120, which will be described hereinafter, can be applied to the electrostatic discharge circuit 120 that is formed not only on a portion ("A" of FIG. 1) but also on all other areas of the substrate 110.

**[0031]** Referring to FIGS. 2 and 3, the electrostatic discharge circuit 120 of the organic light emitting display 100 according to a preferred embodiment of the invention includes a buffer layer 121 formed on the top of the substrate 110, a gate insulating layer 122 formed on the top of the buffer layer 121, a gate electrode 123 (optionally referred to as a "first electrode layer") formed on the top of the gate insulating layer 122, an insulating interlayer 124 (optionally referred to as a "first insulating layer") formed to cover the gate electrode 123, and a source/drain electrode 125 (optionally referred to as a "second electrode layer") formed on the top of the insulating interlayer 124. Furthermore, the electrostatic discharge circuit 120 can further include a first protective layer 126 formed to cover the source/drain electrode 125, a second protective layer 127, and a third electrode layer 128 which is formed on the top surface of the second protective layer 127 and is electrically coupled with the source/drain electrode 125. In some embodiments, the gate electrode 123 can include a first protruding electrode 123a formed to extend horizontally. Furthermore, the source/drain electrode 125 can include a second protruding electrode 125a formed to extend horizontally.

**[0032]** The substrate 110 is formed in the form of a plate with top and bottom surfaces, and the thickness between the top and bottom surfaces is from about 0.05mm to about 1mm. If the thickness of the substrate 110 is below about 0.05mm, a disadvantage is caused that the substrate is liable to damage during cleaning, etching and heat treatment processes and has a low resistance to an external force. Moreover, if the thickness of the substrate 110 is above about 1mm, it is difficult to apply the substrate to various display devices that are thin. The substrate 110 can be formed of at least one of an ordinary glass, a plastic, a stainless steel and their equivalents, but not limited thereto. The substrate 110 may be formed by pre-compacting the substrate 110 to prevent it from being readily deformed due to a heat or a pressure in the step of cleaning the substrate to prevent it from containing foreign substances and in the step of manufacturing other components. The substrate 110 can be divided into the pixel area 110a including the thin film transistor and the organic light emitting diode and the non-pixel area 110b on which various drivers are formed.

**[0033]** The buffer layer 121 serves at least for preventing moisture (H<sub>2</sub>O), hydrogen (H<sub>2</sub>), oxygen (O<sub>2</sub>), etc. from penetrating through the substrate 110 and infiltrating into the electrostatic discharge circuit 120. For this purpose, the buffer layer 121 can be formed of a silicon oxide layer (SiO<sub>2</sub>) a silicon nitride layer (Si<sub>3</sub>N<sub>4</sub>), an organic layer and their equivalents that can be easily formed during a semiconductor process, but not limited thereto. Of course, the buffer layer 121 can be formed in a multilayer structure, or can be omitted.

**[0034]** The gate insulating layer 122 is formed on the top surface of the buffer layer 121. The gate insulating layer 122 is formed between the gate electrode 123, which will be described later, and the buffer layer 121 to

obtain the electrical desired insulating. The gate insulating layer 122 can be formed of any of a silicon oxide layer, a silicon nitride layer, an organic layer or their equivalents that can be easily formed during a semiconductor process, but not limited thereto. The gate insulating layer 122 can be formed by any of a PECVD method, an LPCVD method, a sputtering method and other methods.

**[0035]** The gate electrode 123 is formed on the top of the gate insulating layer 122. The gate electrode 123 can be electrically coupled with the ground pad 160a (see FIG. 1) included in the pad 160 (see FIG. 1). The gate electrode 123 can be, for example, formed of any of aluminum (Al), aluminum-neodymium (AlNd), chrome (Cr), molybdenum (Mo), molybdenum-tungsten (MoW) and titanium (Ti) or can be formed of a metal material made by their combinations, but is not limited thereto. After being deposited on the gate insulating layer 122, the gate electrode 123 can be positioned at the desired position in the desired number through processes of applying a photoresist, exposing, developing, etching, separating the photoresist and so on. The gate electrode 123 serves for inducing the break down of the insulating interlayer 124, which will be described later, and discharging the static electricity. Furthermore, the gate electrode 123 can ground the static electricity by the ground pad 160a included in the pad 160 (see FIG. 1). The gate electrode 123 can include the first protruding electrode 123a for inducing relatively easily the electrostatic discharge.

**[0036]** The first protruding electrode 123a is formed to extend horizontally toward the source/drain electrode 125, which will be described later, in the gate electrode 123. As shown in FIG. 2, the first protruding electrode 123a can be formed in the shape of a saw-tooth formed in a portion of the gate electrode 123. Furthermore, the first protruding electrode 123a can be formed integrally with the gate electrode 123 and can be formed simultaneously with the gate electrode 123 in the process of forming the gate electrode 123. The first protruding electrode 123a can be formed such that its end e1 points toward the source/drain electrode 125 or the second protruding electrode 125a included in the source/drain electrode 125. The end e1 of the first protruding electrode 123a is formed in an angular shape for allowing the static electricity charge to be concentrated for a relatively short time. The first protruding electrode 123a is formed opposite to the second protruding electrode 125a which will be described later. In case that the electrostatic discharge occurs in the gate electrode 123, the first protruding electrode 123a serves for concentrating the static electricity charge to the angular end e1 and forming a high electric field. The shape of the first protruding electrode 123a is not limited to that shown in FIG. 2, however, the first protruding electrode can be formed in spike or tooth having an angular shape that allows the static electricity charge to be concentrated.

**[0037]** The insulating interlayer 124 is formed on top of the gate electrode 123. Of course, the insulating interlayer 124 can also be formed on the gate insulating layer

122 which is formed on the outer circumference of the gate electrode 123. The insulating interlayer 124 can be formed of the same insulating material as the gate insulating layer 122 and may include a silicon oxide layer, a silicon nitride layer, an organic layer and so on, but is not limited thereto. The insulating interlayer 124 can be formed of any of a polymer-based insulating material, a plastic-based insulating material, a glass-based insulating material and their equivalents, but is not limited thereto. The insulating interlayer 124 serves for inducing the break down of insulation by the static electricity applied through the gate electrode 123 or the source/drain electrode 125.

**[0038]** The source/drain electrode 125 is formed on top of the insulating interlayer 124. The source/drain electrode 125 can be formed on the top of the insulating interlayer 124. The source/drain electrode 125 can be formed to be spaced apart from the gate electrode 123 in the horizontal direction. The source/drain electrode 125 can be electrically coupled with the ground pad 160a (see FIG. 1) formed on the pad 160 (see FIG. 1). The source/drain electrode 125 serves for inducing the break down of insulation of the insulating interlayer 124 formed between the source/drain electrode 125 and the gate electrode 123 and discharging the static electricity. The source/drain electrode 125 can ground the static electricity through the ground pad 160a (see FIG. 1). The source/drain electrode 125 can be formed of the same metal material as the gate electrode 123, but is not limited thereto. The source/drain electrode 125 can be deposited by any of, for example, a PECVD method, an LPCVD method, a sputtering method and their equivalent methods, and then can be patterned at the desired position in the desired number through processes of, for example, applying a photoresist, exposing, developing, etching and separating the photoresist. On the other hand, the source/drain electrode 125 can include the second protruding electrode 125a formed to extend horizontally in the source/drain electrode 125.

**[0039]** The second protruding electrode 125a is formed to extend horizontally toward the gate electrode 123 in the source/drain electrode 125. As shown in FIG. 2, the second protruding electrode 125a can be formed in the shape of a saw-tooth formed continuously in a portion of the source/drain electrode 125. Furthermore, the second protruding electrode 125a can be formed integrally with the source/drain electrode 125 and can be formed simultaneously with the source/drain electrode 125 in the process of forming the source/drain electrode 125. The second protruding electrode 125a can be formed such that its end e2 points toward the gate electrode 123 or the first protruding electrode 123a included in the gate electrode 123. Similarly to the end e1 of the first protruding electrode 123a, the end e2 of the second protruding electrode 125a can be formed in an angular shape for allowing the static electricity charge to be concentrated. In case that the electrostatic discharge occurs in the source/drain electrode 125, the second protruding

electrode 125a serves for concentrating the static electricity charge to the angular end e2 and forming a high electric field.

**[0040]** Meanwhile, the distance (in the horizontal direction) between the source/drain electrode 125 and the gate electrode 123 can be varied depending on the voltage level of the static electricity to be controlled and the area of the electrostatic discharge circuit 120 to be formed in the non-pixel area 110b. 10b. If the voltage level of the static electricity to be controlled is relatively high (for example, above a few thousand volts), then the distance (in the horizontal direction) between the source/drain electrode 125 and the gate electrode 123 is formed as long as possible within the area able to forming the electrostatic discharge circuit 120. However, the distance (in the horizontal direction) between the source/drain electrode 125 and the gate electrode 123 is not limited.

**[0041]** The electrostatic discharge circuit 120 can further include a protective layer formed on the source/drain electrode 125. The protective layer can include the first protective layer 126 and the second protective layer 127. The first protective layer 126 is formed to cover the source/drain electrode 125 and the insulating interlayer 124 and serves for protecting the source/drain electrode 125 and the gate electrode 123. The first protective layer 126 can be formed of any one selected from an ordinary organic layer and its equivalents, but is not limited thereto. Furthermore, the second protective layer 127 is formed to cover the first protective layer 126 and serves for aiding the surface of the electrostatic discharge circuit 120 to be substantially planar. The second protective layer 127 can be formed of at least one of benzo cyclo butene (BCB), acryl and their equivalents, but is not limited thereto.

**[0042]** Furthermore, the electrostatic discharge circuit 120 can further include the third electrode layer 128 on the top surface of the second protective layer 127. The third electrode layer 128 is electrically coupled with the source/drain electrode 125 through an electrically conductive via hole v1. The third electrode layer 128 can be formed of the same metal material as the gate electrode 123 and the source/drain electrode 125, but is not limited thereto. The third electrode layer 128 aids the static electricity to be discharged to the source/drain electrode 125 through the electrically conductive via hole v1 when the static electricity is generated.

**[0043]** According to the above-mentioned embodiment, the electrostatic discharge circuit 120 is formed on at least one side of the non-pixel area 110b which is on the outer circumference of the pixel area 110a of the organic light emitting display 100, and prevents the pixels P and the drivers 130, 140 and 150 from being damaged due to the electrostatic discharge.

**[0044]** More specifically, the electrostatic discharge current is conducted through the insulating interlayer 124 between the gate electrode 123 and the source/drain electrode 125. The static electricity from the gate electrode 123 or the source/drain electrode 125 is discharged

by the break down of insulation of the insulating interlayer 124. A portion of the static electricity can be grounded by any one of the gate electrode 123 and the source/drain electrode 125. Furthermore, the static electricity generated in the outside of the electrostatic discharge circuit 120 can be transferred to the source/drain electrode 125 through the third electrode layer 128 and can be discharged thereby.

**[0045]** The electrostatic discharge circuit 120 has an advantageous effect that allows the static electricity to be relatively easily dissipated with the first protruding electrode 123a and the second protruding electrode 125a which form a high electric field due to the concentration of the static electricity charge and thus facilitating the break down of the insulation.

**[0046]** More specifically, the ends e1 and e2 of the first and second protruding electrodes 123a and 125a are formed in an angular shape. Hence, the static electricity charge is concentrated at the ends e1 and e2 when the static electricity is generated, and thus relatively high electric field can be formed at the ends e1 and e2. The end e1 of the first protruding electrode 123a and the end e2 of the second protruding electrode 125a face each other, and the break down of insulation of the insulating interlayer 124 between the first protruding electrode 123a and the second protruding electrode 125a by the electrostatic discharge is facilitated. Accordingly, the electrostatic discharge can be dissipated more easily by the first protruding electrode 123a and the second protruding electrode 125a.

**[0047]** Next, another example of the protruding electrodes 123a and 125a in the electrostatic discharge circuit 120 will be described.

**[0048]** FIG. 4 is a view showing a portion, which corresponds to FIG. 2, of another electrostatic discharge circuit 120', and FIG. 5 is a view showing other shapes of protruding electrodes 123a' and 125a' of FIG. 4.

**[0049]** The electrostatic discharge circuit 120' is similar to that of the electrostatic discharge circuit 120 of FIGS. 2 and 3. An explanation of the protruding electrodes 123a' and 125a' will be made hereinafter.

**[0050]** The electrostatic discharge circuit 120' includes a first protruding electrode 123a' formed to extend horizontally in the gate electrode 123 and a second protruding electrode 125a' formed to extend horizontally in the source/drain electrode 125.

**[0051]** The first protruding electrode 123a' and the second protruding electrode 125a' can be formed on at least a portion of the gate electrode 123 and the source/drain electrode 125 in the form of a triangle, respectively. The first protruding electrode 123a' and the second protruding electrode 125a' can be formed such that one side thereof is formed on the gate electrode 123 and the source/drain electrode 125 and a vertex which is opposite to the one side points toward the opposite electrode respectively. That is, in the first protruding electrode 123a' and the second protruding electrode 125a' formed in the form of a triangle, the above-mentioned vertices can be ends e1'

and e2'. The end e1' of the first protruding electrode 123a' and the end e2' of the second protruding electrode 125a' can be formed facing each other. As described above, the ends e1' and e2', which are formed on the protruding electrodes 123a' and 125a' respectively, are formed as the vertices, and thus perform similarly to the operation as the above-described embodiment. The static electricity charge transferred through the gate electrode 123 and the source/drain electrode 125 is concentrated to the ends e1' and e2', and relatively high electric field is formed between the ends e1' and e2', and thus the break down of insulation between the gate electrode 123 and the source/drain electrode 125 (the break down of insulation through the insulating interlayer 124) can be facilitated.

**[0052]** As shown in FIG. 5, each of the first protruding electrode 123a' and the second protruding electrode 125a' can be formed in the form of any of a pentagon a2' and a trapezoid a3'. However, the shapes of the first protruding electrode 123a' and the second protruding electrode 125a' are not limited thereto, and the shapes thereof can be varied.

**[0053]** The first protruding electrode 123a' and the second protruding electrode 125a' have an advantageous aspect that they can be formed at the desired position of the gate electrode 123 and the source/drain electrode 125 in the desired number respectively. Accordingly, by forming the protruding electrodes 123a' and 125a' on a portion where the static electricity is intensively generated or a portion vulnerable to the static electricity, the break down of insulation by the static electricity can be more easily induced.

**[0054]** Next, an organic light emitting display according to another embodiment will be described hereinafter.

**[0055]** FIG. 6 is a plan view showing a portion, which corresponds to FIG. 2, of an organic light emitting display according to another embodiment, and FIG. 7 is a vertical cross-sectional view taken along the line II-II of FIG. 6. Since the organic light emitting display of this embodiment is similar to that of the embodiment shown in FIGS. 1 to 4, an explanation emphasizing the different features will be made hereinafter.

**[0056]** Referring to FIGS. 6 and 7, an electrostatic discharge circuit 220 of the organic light emitting display according to this embodiment includes a buffer layer 221 formed on the top of a substrate 210, a semiconductor layer 229 formed on the top of the buffer layer 221, a gate insulating layer 222 formed on the top of the semiconductor layer 229, a gate electrode 223 formed on the top of the gate insulating layer 222, an insulating interlayer 224 formed to cover the gate electrode 223, and a source/drain electrode 225 formed on the top of the insulating interlayer 224. Furthermore, the electrostatic discharge circuit 220 can further include a first protective layer 226 formed to cover the source/drain electrode 225, a second protective layer 227, and a third electrode layer 228 which is formed on the top surface of the second protective layer 227 and is electrically coupled with the

source/drain electrode 225 through a via hole v2. The gate electrode 223 can include a first protruding electrode 223a formed to extend horizontally in the gate electrode 223. Furthermore, the source/drain electrode 225 can include a second protruding electrode 225a formed to extend horizontally in the source/drain electrode 225. Some embodiments can be formed with the same structure and material as the above-mentioned embodiments except that the semiconductor layer 229 is formed on the top of the buffer layer 221.

**[0057]** The semiconductor layer 229 can be formed on the buffer layer 221 or the substrate 210. The semiconductor layer 229 serves for inducing the electrostatic discharge together with the gate electrode 23 and the source/drain electrode 225. The semiconductor layer 229 can be formed of any one selected from amorphous silicon, micro silicon (silicon having a grain size between amorphous silicon and polycrystalline silicon), an organic matter and their equivalents, but is not limited thereto. The semiconductor layer 229 can be electrically coupled with the source/drain electrode 225 through an electrically conductive contact c1 that is formed to penetrate the insulating interlayer 224. The semiconductor layer 229 includes source and drain areas (not shown) formed on both sides opposite to each other, a channel area (not shown) formed between the source and drain areas. After crystallizing amorphous silicon or micro silicon into polycrystalline silicon, the semiconductor layer 229 can be formed in the desired position and shape through patterning.

**[0058]** The amorphous silicon can be crystallized by a laser crystallization method using an excimer laser, a metal induced crystallization (MIC) method using a metal promoting material, and a solid phase crystallization (SPC) method. Furthermore, there is a sequential lateral solidification (SLS) method which further uses a mask in the existing laser crystallization method. The laser crystallization method is the most widely used method. According to the laser crystallization method, it is possible to use the existing crystallization method of a polycrystalline liquid crystal display, the processing method is simple, and the technical development about the processing method has been completed.

**[0059]** The metal induced crystallization method is one of methods that can crystallize at a low temperature without using the laser crystallization method. The metal induced crystallization method has an advantageous effect in that a metal promoting material such as Ni, Co, Pd, Ti, etc. is initially deposited or spin-coated on the surface of the amorphous silicon, and then the metal promoting material is directly penetrated into the surface of the amorphous silicon, thereby crystallizing the amorphous silicon at a low temperature while changing the phase thereof.

**[0060]** Another metal induced crystallization method that uses a mask when applying a metal layer on the surface of the amorphous silicon is to prevent a contaminant such as a nickel silicide from depositing on a specific area of a thin film transistor. This crystallization method

is referred to as a metal induced lateral crystallization (MILC) method. The mask used for the metal induced lateral crystallization method may be a shadow mask, and the shadow mask may be a linear mask or a dotted mask.

**[0061]** Another metal induced crystallization method is a metal induced crystallization with capping layer (MICC) method which applies the capping layer on the surface of the amorphous silicon before depositing or spin-coating the metal promoting material layer thereon and controls the amount of a metal promoting material introduced into the amorphous silicon. As the capping layer, a silicon nitride layer can be used. The amount of the metal promoting material to be introduced into the amorphous silicon from the metal promoting material layer varies depending on the thickness of the silicon nitride layer. At this time, the metal promoting material introduced into the silicon nitride layer can be formed on the entire silicon nitride layer or can be selectively formed by using the shadow mask. After the metal promoting material layer crystallizes the amorphous silicon into the polycrystalline silicon, it is possible to selectively remove the capping layer. As a method for removing the capping layer, a wet etching method or a dry etching method can be used.

**[0062]** The micro silicon typically refers to silicon having a crystal grain size of 1nm to 100nm. The micro silicon is characterized in that its electron mobility is from 1 to 50 and its hole mobility is from 0.01 to 0.2. The micro silicon is characterized in that its crystal grain size is smaller than that of the polycrystalline silicon. Furthermore, a protrusion area between crystal grains of the micro silicon is formed small, and thus electron movement between the crystal grains does not hindered, thereby exhibiting uniform characteristics. As a method for crystallizing the micro silicon, there are a thermal crystallization method and a laser crystallization method. The thermal crystallization method includes a method that obtains a crystallization structure simultaneously with the deposition of the amorphous silicon, and a reheating method. The laser crystallization method is a crystallization method that crystallizes using a laser after depositing the amorphous silicon by a chemical vapor deposition method, and the laser employed is mainly a diode laser. The diode laser mainly uses a red wavelength of 800nm range, and the red wavelength serves for allowing the micro silicon to be uniformly crystallized.

**[0063]** The polycrystalline silicon formed by the above-mentioned method is positioned at the desired position in the desired number through processes of applying a photoresist, exposing, developing, etching, separating the photoresist and so on.

**[0064]** In the source/drain electrode 225, an electrode contacted with the source area and the drain area is integrally formed. Hence, the electrostatic discharge circuit 220 is not operated when a usual driving voltage is applied.

**[0065]** Meanwhile, the first protruding electrode 223a and the second protruding electrode 225a according to

another embodiment can be formed in a similar manner as the first protruding electrode 123a and the second protruding electrode 125a of the above-mentioned embodiments, and the operation of the first protruding electrode 223a and the second protruding electrode 225a is similar to the operation of the first protruding electrode 123a and the second protruding electrode 125a.

**[0066]** According to the above-mentioned embodiments, the electrostatic discharge circuit 220 has an advantageous effect that since the static electricity can be discharged through the insulating interlayer 224 formed between the gate electrode 223 and the source/drain electrode 225 and the electrostatic discharge current can be conducted through the gate insulating layer 222 formed between the gate electrode 223 and the semiconductor layer 229 or through the gate insulating layer 222 and the insulating interlayer 224 between the source/drain electrode 225 and the semiconductor layer 229, it is possible to dissipate the electrostatic discharge by using other paths also.

**[0067]** Furthermore, by forming the first protruding electrode 223a and the second protruding electrode 225a, at which the static electricity is concentrated, on the gate electrode 223 and the source/drain electrode 225, it is possible to dissipated more easily the electrostatic discharge current. The operation of the first protruding electrode 223 and the second protruding electrode 225a is similar to the operation of the above-mentioned embodiments.

**[0068]** FIG. 8 is a schematic view showing an organic light emitting display according to yet another embodiment.

**[0069]** Referring to FIG. 8, the organic light emitting display 300 according to yet another embodiment includes an electrostatic discharge circuit 320 that is separately formed on each side of a substrate 310 including a pixel area 310a and a non-pixel area 310b. Hence, it is an advantageous effect that the electrostatic discharge circuit 320 can be selectively formed only on an area where the electrostatic discharge is expected to occur, or another desired area. According to yet another embodiment each electrostatic discharge circuit 320 can be electrically coupled with a ground pad (not shown) of a pad 360 formed on the substrate 310. The detailed structure of the electrostatic discharge circuit 320 according to this embodiment can be formed in a similar manner as the above-mentioned embodiments and the operation and the advantageous effect of the electrostatic discharge circuit 320 is also similar the above-mentioned embodiments.

**[0070]** The organic light emitting diode included in the pixel P comprises, for example, an anode (ITO), an organic layer and a cathode (metal). The organic layer can be composed of an emitting layer (EML) which emits light by recombining electrons and holes and forming excitons, an electron transport layer (ETL) which transports electrons, and a hole transport layer (HTL) which transports holes. Furthermore, an electron injecting layer (EIL)

which injects electrons can be formed on one side of the electron transport layer, and a hole injecting layer (HIL) which injects holes can be formed on one side of the hole transport layer. Moreover, in case of a phosphorescent organic light emitting diode, a hole blocking layer (HBL) can be selectively formed between the emitting layer (EML) and the electron transport layer (ETL), and an electron blocking layer (EBL) can be selectively formed between the emitting layer (EML) and the hole transport layer (HTL).

**[0071]** Furthermore, the organic layer can be formed as a slim organic light emitting diode with two kinds of layers with reduced thickness. For example, it is possible to selectively form a hole injection transport layer (HITL) forming the hole injecting layer and the hole transport layer simultaneously and an electron injection transport layer (EITL) forming the electron injecting layer and the electron transport layer simultaneously. The slim organic light emitting diode is used to increase the light emission efficiency. Furthermore, a buffer layer can be formed between the anode (ITO) and the emitting layer as an optional layer. The buffer layer is divided into an electron buffer layer for buffering an electron and a hole buffer layer for buffering a hole.

**[0072]** The electron buffer layer can be selectively formed between the cathode (metal) and the electron injecting layer (EIL) and can function as a substitute for the electron injecting layer (EIL). The stack structure of the organic layer can be the emission layer (EML)/electron transport layer (ETL)/electron buffer layer/cathode (metal). Furthermore, the hole buffer layer can be selectively formed between the anode (ITO) and the hole injecting layer (HIL) and can function as a substitute for the hole injecting layer (HIL). At this time, the stack structure of the organic layer can be the anode (ITO)/hole buffer layer/hole transport layer (HTL)/emission layer (EML).

**[0073]** Possible stack structures are as follows:

**[0074]** a) Normal Stack Structure

- 1) the anode/hole injecting layer/hole transport layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 2) the anode/hole buffer layer/hole injecting layer/hole transport layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 3) the anode/hole injecting layer/hole transport layer/emitting layer/electron transport layer/electron injecting layer/electron buffer layer/cathode
- 4) the anode/hole buffer layer/hole injecting layer/hole transport layer/emitting layer/electron transport layer/electron injecting layer/electron buffer layer/cathode
- 5) the anode/hole injecting layer/hole buffer layer/hole transport layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 6) the anode/hole injecting layer/hole transport layer/emitting layer/electron transport layer/electron buff-

er layer/electron injecting layer/cathode

**[0075]** b) Normal Slim Structure

- 5 1) the anode/hole injection transport layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 2) the anode/hole buffer layer/hole injection transport layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 10 3) the anode/hole injecting layer/hole transport layer/emitting layer/electron injection transport layer/electron buffer layer/cathode
- 4) the anode/hole buffer layer/hole transport layer/emitting layer/electron injection transport layer/electron buffer layer/cathode
- 15 5) the anode/hole injection transport layer/hole buffer layer/emitting layer/electron transport layer/electron injecting layer/cathode
- 20 6) the anode/hole injecting layer/hole transport layer/emitting layer/electron buffer layer/electron injection transport layer/cathode

**[0076]** c) Inverted Stack Structure

- 25 1) the cathode/electron injecting layer/electron transport layer/emitting layer/hole transport layer/hole injecting layer/anode
- 2) the cathode/electron injecting layer/electron transport layer/emitting layer/hole transport layer/hole injecting layer/hole buffer layer/anode
- 30 3) the cathode/electron buffer layer/electron injecting layer/electron transport layer/emitting layer/hole transport layer/hole injecting layer/anode
- 4) the cathode/electron buffer layer/electron injecting layer/electron transport layer/emitting layer/hole transport layer/hole buffer layer/anode
- 35 5) the cathode/electron injecting layer/electron transport layer/emitting layer/hole transport layer/hole buffer layer/anode
- 40 6) the cathode/electron injecting layer/electron buffer layer/electron transport layer/emitting layer/hole transport layer/hole injecting layer/anode

**[0077]** d) Inverted Slim Structure

- 45 1) the cathode/electron injecting layer/electron transport layer/emitting layer/hole injection transport layer/anode
- 2) the cathode/electron injecting layer/electron transport layer/emitting layer/hole injection transport layer/hole buffer layer/anode
- 50 3) the cathode/electron buffer layer/electron injection transport layer/emitting layer/hole transport layer/hole injecting layer/anode
- 4) the cathode/electron buffer layer/electron injection transport layer/emitting layer/hole transport layer/hole buffer layer/anode
- 55

5) the cathode/electron injecting layer/electron transport layer/emitting layer/hole buffer layer/hole injection transport layer/anode

6) the cathode/electron injection transport layer/electron buffer layer/emitting layer/hole transport layer/hole injecting layer/anode

**[0078]** As a method for driving the organic light emitting diode, either a passive matrix method or an active matrix method may be used. The passive matrix method has an advantageous effect of simple manufacturing process and less investment cost by forming the anode and the cathode to intersect at right angles and selecting and driving a line. However, the passive matrix method has a disadvantage of high current consumption when embodying a wide screen. The active matrix method has an advantageous effect of low current consumption, excellent image quality, long service life, and applicability to medium and large sized product by forming an active element such as a thin film transistor and a capacitive element on each pixel.

**[0079]** According to the above-mentioned embodiments, the organic light emitting display is provided on at least one side of the substrate with the electrostatic discharge circuit, and thus can prevent the pixels or the drives from being damaged due to the electrostatic discharge generated by environmental causes, whether internal or external to the display. At this time, the electrostatic discharge circuit includes the protruding electrode that concentrates the static electricity charge and forms a high electric field, and thus can dissipate more easily the electrostatic discharge current.

**[0080]** As described above, the organic light emitting display has an advantageous effect that can prevent the pixels or the drivers from being damaged due to the electrostatic discharge by forming the electrostatic discharge circuit on at least one side of the inner circumference of the substrate.

**[0081]** Furthermore, such an advantageous effect is attained that the break down of insulation between the protruding electrodes can be more facilitated by forming the protruding electrodes to extend horizontally on the gate electrode and the source/drain electrode of the electrostatic discharge circuit respectively, and thus the electrostatic discharge can be more easily dissipated.

**[0082]** Moreover, such an advantageous effect is attained that the electrostatic discharge can be dissipated using the semiconductor layer in addition to the gate electrode and the source/drain electrode by forming the semiconductor layer in the electrostatic discharge circuit, and thus the electrostatic discharge can be dissipated using more various paths.

**[0083]** In addition, such an advantageous effect is attained that the electrostatic discharge circuit can be selectively formed in an area where the electrostatic discharge is expected to occur or another area by separately forming the electrostatic discharge circuit on each side of the inner circumference of the substrate.

**[0084]** Although certain embodiments of the organic light emitting display have been described for illustrative purposes, those skilled in the art will appreciate that various modifications and changes thereof are possible without departing from the scope of the present invention defined in the appended claims.

## Claims

1. An organic light emitting display comprising:

a substrate (110) including a pixel area (110a) and a non-pixel area (110b); and an electrostatic discharge circuit (120) formed in the non-pixel area (110b), the electrostatic discharge circuit (120) comprising:

a first electrode layer (123) having a stripe-shaped main body formed on the substrate (110) and extending along the non-pixel area (110b) of the substrate (110) in a first plane which is parallel to the surface of the substrate (110);

a first insulating layer (124) formed on the first electrode layer (123); and

a second electrode layer (125) having a stripe-shaped main body formed on the first insulating layer (124) extending along the non-pixel area (110b) of the substrate (110) in a second plane which is parallel to the surface of the substrate (110), wherein the main body first electrode layer (123) and the main body second electrode layer (125) are separated from each other in a predetermined distance.

wherein the following conditions (i) and (ii) are met:

(i) the first electrode layer (123) comprises at least one protruding member (123a) which extends in the first plane in a direction perpendicular to the longitudinal axis of the main body first electrode layer (123) toward the second electrode layer (125),

(ii) the second electrode layer (125) comprises at least one protruding member (125a) which extends in the second plane in a direction perpendicular to the longitudinal axis of the main body second electrode layer (125) toward the first electrode layer (123)

### characterized in that

each of the first and second electrode layers (123, 125) comprises a plurality of protruding members (123a, 125a), wherein the plurality of protruding members (123a, 125a) of each of the first and second electrode layers (123, 125) have a uniform distance from adjacent protruding members (123a, 125a), and the protruding members (123a) of the first elec-

- trode layer (123) interdigitate with the protruding members (125a) of the second electrode layer (125), and the protruding members of the first and second electrode layers (123a, 125a) comprise more than one spike and wherein the vertices (e1') of the spikes (123a') of the protruding members of the first electrode layer (123) face the vertices (e2') of the spikes (125a') of the protruding members of the second electrode layer (125).
2. The organic light emitting display according to one of the preceding claims, wherein the main body first electrode layer (123) follows the main body second electrode layer (125) in a uniform distance over at least 90% of its length.
  3. The organic light emitting display according to one of the preceding claims, wherein the substrate (110) comprises a rectangular shape or a square shape, and wherein the electrostatic discharge circuit (120) is arranged to extend along at least one of the edges of the substrate (110).
  4. The organic light emitting display according to claim 3, wherein the electrostatic discharge circuit (120) is arranged to completely extend along at least one edge of the substrate (110).
  5. The organic light emitting display according to one of the claims 3 and 4, wherein the electrostatic discharge circuit (120) is arranged to extend along at least three edges of the substrate (110).
  6. The organic light emitting display according to one of the claims 3 and 5, wherein, wherein the electrostatic discharge circuit (120) has a length of at least 70% of the edge length of the substrate (110).
  7. The organic light emitting display according to one of the preceding claims, wherein the electrostatic discharge circuit (320) further comprises a semiconductor layer (229) formed between the substrate (210) and the first electrode layer (223).
  8. The organic light emitting display as claimed in claim 7, wherein the electrostatic discharge circuit (320) further comprises a second insulating layer (222) formed between the semiconductor layer (229) and the first electrode layer (223) and/or wherein the electrostatic discharge circuit (320) further comprises a buffer layer (221) formed between the substrate (210) and the semiconductor layer (229).
  9. The organic light emitting display according to one of the preceding claims, wherein the electrostatic discharge circuit (120) further comprises a protective layer (126, 127) formed on the second electrode layer (125).
  10. The organic light emitting display as claimed in claim 9, wherein the electrostatic discharge circuit (120) further comprises a third electrode layer (128) formed on the protective layer (126, 127) and is electrically coupled with the second electrode layer (125) through a via hole (v1).
  11. The organic light emitting display according to one of the preceding claims, wherein the non-pixel area (110b) further comprises:
    - at least one driver (130, 140, 150) configured to drive a pixel in the pixel area (110a); and
    - a pad (160) configured to electrically couple the pixel and the driver with an external module.
  12. The organic light emitting display as claimed in claim 11, wherein the pad (160) is formed on an inner portion of at least one edge of the substrate (110).
  13. The organic light emitting display as claimed in claim 12, wherein the electrostatic discharge circuit (120) is formed to extend along at least one edge of the substrate (110) other than the edge on which the pad (160) is formed.
  14. The organic light emitting display according to one of the preceding claims, wherein one electrostatic discharge circuit (320) is separately formed on each edge of the inner circumference of the substrate (110).
  15. The organic light emitting display according to one of the claims 1-13, wherein the electrostatic discharge circuit (120) is integrally formed to substantially surround the inner circumference of the substrate (110).
  16. The organic light emitting display according to one of the claims 11-15, wherein any of the first electrode layer (123) and the second electrode layer (125) is electrically coupled with a ground pad (160).
  17. The organic light emitting display according to one of the preceding claims, wherein the first electrode layer (123) and the second electrode layer (125) comprises at least one of aluminum, aluminum-neodymium, chrome, molybdenum, molybdenum-tungsten and titanium and/or wherein the first insulating layer (124) comprises at least one of silicon oxide, silicon nitride and an organic matter.

## Patentansprüche

1. Organisches, Licht emittierendes Display, umfas-

send:

ein Substrat (110) mit einem Pixelbereich (110a) und einem Nicht-Pixelbereich (110b); und eine im Nicht-Pixelbereich (110b) ausgebildete Schaltung zur elektrostatischen Entladung (120), wobei die Schaltung zur elektrostatischen Entladung (120) umfasst:

eine erste Elektrodenschicht (123), die einen auf dem Substrat (110) ausgebildeten streifenförmigen Hauptkörper aufweist und sich in einer ersten, parallel zur Oberfläche des Substrats (110) liegenden Ebene entlang des Nicht-Pixelbereichs (110b) des Substrats (110) erstreckt;

eine erste Isolierschicht (124), die auf der ersten Elektrodenschicht (123) ausgebildet ist; und

eine zweite Elektrodenschicht (125), die einen auf der ersten Isolierschicht (124) ausgebildeten streifenförmigen Hauptkörper aufweist, der sich in einer zweiten, parallel zur Oberfläche des Substrats (110) liegenden Ebene entlang des Nicht-Pixelbereichs (110b) des Substrats (110) erstreckt, wobei der Hauptkörper der ersten Elektrodenschicht (123) und der Hauptkörper der zweiten Elektrodenschicht (125) in einem vorbestimmten Abstand voneinander getrennt sind,

wobei die folgenden Bedingungen (i) und (ii) erfüllt sind:

(i) die erste Elektrodenschicht (123) umfasst mindestens ein hervorstehendes Element (123a), das sich in der ersten Ebene in lotrechter Richtung zur Längsachse des Hauptkörpers der ersten Elektrodenschicht (123) zur zweiten Elektrodenschicht (125) hin erstreckt,

(ii) die zweite Elektrodenschicht (125) umfasst mindestens ein hervorstehendes Element (125a), das sich in der zweiten Ebene in lotrechter Richtung zur Längsachse des Hauptkörpers der zweiten Elektrodenschicht (125) zur ersten Elektrodenschicht (123) hin erstreckt,

**dadurch gekennzeichnet, dass**

die erste und zweite Elektrodenschicht (123, 125) jeweils eine Vielzahl hervorstehender Elemente (123a, 125a) umfassen, wobei die Vielzahl hervorstehender Elemente (123a, 125a) der ersten und zweiten Elektrodenschicht (123, 125) jeweils einen einheitlichen Abstand von benachbarten hervorstehenden Elementen (123a, 125a) aufweisen und die

hervorstehenden Elemente (123a) der ersten Elektrodenschicht (123) in die hervorstehenden Elementen (125a) der zweiten Elektrodenschicht (125) greifen, und

die hervorstehenden Elemente der ersten und zweiten Elektrodenschicht (123a, 125a) mehr als einen Dorn umfassen,

und wobei die Spitzen (e1') der Dorne (123a') der hervorstehenden Elemente der ersten Elektrodenschicht (123) zu den Spitzen (e2') der Dorne (125a') der hervorstehenden Elemente der zweiten Elektrodenschicht (125) hin weisen.

2. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei der Hauptkörper der ersten Elektrodenschicht (123) dem Hauptkörper der zweiten Elektrodenschicht (125) über mindestens 90 % seiner Länge in einem einheitlichen Abstand folgt.

3. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei das Substrat (110) eine rechteckige oder quadratische Form aufweist und wobei die Schaltung zur elektrostatischen Entladung (120) so angeordnet ist, dass sie sich entlang mindestens einer der Kanten des Substrats (110) erstreckt.

4. Organisches, Licht emittierendes Display nach Anspruch 3, wobei die Schaltung zur elektrostatischen Entladung (120) so angeordnet ist, dass sie sich vollständig entlang mindestens einer Kante des Substrats (110) erstreckt.

5. Organisches, Licht emittierendes Display nach einem der Ansprüche 3 und 4, wobei die Schaltung zur elektrostatischen Entladung (120) so angeordnet ist, dass sie sich entlang mindestens dreier Kanten des Substrats (110) erstreckt.

6. Organisches, Licht emittierendes Display nach einem der Ansprüche 3 und 5, wobei die Schaltung zur elektrostatischen Entladung (120) eine Länge von mindestens 70 % der Kantenlänge des Substrats (110) aufweist.

7. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei die Schaltung zur elektrostatischen Entladung (320) weiterhin eine Halbleiterschicht (229) umfasst, die zwischen dem Substrat (210) und der ersten Elektrodenschicht (223) ausgebildet ist.

8. Organisches, Licht emittierendes Display nach Anspruch 7, wobei die Schaltung zur elektrostatischen Entladung (320) weiterhin eine zweite Isolierschicht (222) umfasst, die zwischen der Halbleiterschicht (229) und der ersten Elektrodenschicht (223) aus-

- gebildet ist, und/oder wobei die Schaltung zur elektrostatischen Entladung (320) weiterhin eine Pufferschicht (221) umfasst, die zwischen dem Substrat (210) und der Halbleiterschicht (229) ausgebildet ist.
9. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei die Schaltung zur elektrostatischen Entladung (120) weiterhin eine auf der zweiten Elektrodenschicht ausgebildete Schutzschicht (126, 127) umfasst.
10. Organisches, Licht emittierendes Display nach Anspruch 9, wobei die Schaltung zur elektrostatischen Entladung (120) weiterhin eine dritte Elektrodenschicht (128) umfasst, die auf der Schutzschicht (126, 127) ausgebildet und über eine Bohrung (v1) elektrisch mit der zweiten Elektrodenschicht (125) verbunden ist.
11. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei der Nicht-Pixelbereich (110b) weiterhin umfasst:
- mindestens einen Treiber (130, 140, 150) der für das Treiben eines Pixels im Pixelbereich (110a) konfiguriert ist; und  
eine Anschlussfläche (160), die zur elektrischen Verbindung des Pixels und des Treibers mit einem externen Modul konfiguriert ist.
12. Organisches, Licht emittierendes Display nach Anspruch 11, wobei die Anschlussfläche (160) auf einem innen liegenden Teil mindestens einer Kante des Substrats (110) ausgebildet ist.
13. Organisches, Licht emittierendes Display nach Anspruch 12, wobei die Schaltung zur elektrostatischen Entladung (120) so ausgebildet ist, dass sie sich entlang mindestens einer Kante des Substrats (110) erstreckt, jedoch nicht entlang der Kante, auf der die Anschlussfläche (160) ausgebildet ist.
14. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei die Schaltung zur elektrostatischen Entladung (320) separat auf jeder einzelnen Kante des Innenumfangs des Substrats (110) ausgebildet ist.
15. Organisches, Licht emittierendes Display nach einem der Ansprüche 1-13, wobei die Schaltung zur elektrostatischen Entladung (120) in einem Stück ausgebildet ist, so dass sie den Innenumfang des Substrats (110) im Wesentlichen umgibt.
16. Organisches, Licht emittierendes Display nach einem der Ansprüche 11-15, wobei die erste Elektrodenschicht (123) bzw. die zweite Elektrodenschicht (125) elektrisch mit einem Erdungskontakt verbun-

den ist.

17. Organisches, Licht emittierendes Display nach einem der vorangehenden Ansprüche, wobei die erste Elektrodenschicht (123) und die zweite Elektrodenschicht (125) mindestens Aluminium, Aluminium-Neodym, Chrom, Molybdän, Molybdän-Wolfram oder Titan umfassen und/oder wobei die erste Isolierschicht (124) mindestens Siliciumoxid, Siliciumnitrid oder eine organische Substanz umfasst.

## Revendications

1. Afficheur électroluminescent organique comprenant :

un substrat (110) incluant une zone (110a) de pixels et une zone (110b) sans pixels ; et un circuit (120) de décharge électrostatique formé dans la zone (110b) sans pixels, le circuit (120) de décharge électrostatique comprenant :

une première couche (123) d'électrode ayant un corps principal en forme de bande formé sur le substrat (110) et s'étendant le long de la zone (110b) sans pixels du substrat (110) dans un premier plan qui est parallèle à la surface du substrat (110) ;  
une première couche isolante (124) formée sur la première couche (123) d'électrode ;  
et  
une deuxième couche (125) d'électrode ayant un corps principal en forme de bande formé sur la première couche isolante (124) s'étendant le long de la zone (110b) sans pixels du substrat (110) dans un second plan qui est parallèle à la surface du substrat (110), dans lequel le corps principal de la première couche (123) d'électrode et le corps principal de la deuxième couche (125) d'électrode sont séparés l'un de l'autre par une distance prédéterminée, dans lequel les conditions (i) et (ii) suivantes sont satisfaites :

- (i) la première couche (123) d'électrode comprend au moins un élément en saillie (123a) qui s'étend dans le premier plan dans une direction perpendiculaire à l'axe longitudinal du corps principal de la première couche (123) d'électrode en direction de la deuxième couche (125) d'électrode ;  
(ii) la deuxième couche (125) d'électrode comprend au moins un élément en saillie (125a) qui s'étend dans le second plan dans une direction perpen-

diculaire à l'axe longitudinal du corps principal de la deuxième couche (125) d'électrode en direction de la première couche (123) d'électrode,

- caractérisé en ce que** chacune des première et deuxième couches (123, 125) d'électrode comprend une pluralité d'éléments en saillie (123a, 125a), dans lequel les éléments de la pluralité d'éléments en saillie (123a, 125a) de chacune des première et deuxième couches (123, 125) d'électrode ont une distance uniforme par rapport aux éléments en saillie adjacents (123a, 125a), et les éléments en saillie (123a) de la première couche (123) d'électrode sont interdigités avec les éléments en saillie (125a) de la deuxième couche (125) d'électrode, et les éléments en saillie (123a, 125a) des première et deuxième couches d'électrode comprennent plus d'une pointe, et dans lequel les sommets (e1') des pointes (123a') des éléments en saillie de la première couche (123) d'électrode sont en face des sommets (e2') des pointes (125a') des éléments en saillie de la deuxième couche (125) d'électrode.
2. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel le corps principal de la première couche (123) d'électrode suit le corps principal de la deuxième couche (125) d'électrode à une distance uniforme sur au moins 90 % de sa longueur.
  3. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel le substrat (110) présente une forme rectangulaire ou une forme carrée, et dans lequel le circuit (120) de décharge électrostatique est agencé pour s'étendre le long d'au moins un des côtés du substrat (110).
  4. Afficheur électroluminescent organique selon la revendication 3, dans lequel le circuit (120) de décharge électrostatique est agencé pour s'étendre complètement le long d'au moins un côté du substrat (110).
  5. Afficheur électroluminescent organique selon l'une des revendications 3 et 4, dans lequel le circuit (120) de décharge électrostatique est agencé pour s'étendre le long d'au moins trois côtés du substrat (110).
  6. Afficheur électroluminescent organique selon l'une des revendications 3 et 5, dans lequel le circuit (120) de décharge électrostatique a une longueur d'au moins 70 % de la longueur de côté du substrat (110).
  7. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel le circuit (320) de décharge électrostatique comprend en outre une couche semi-conductrice (229) formée entre le substrat (210) et la première couche (223) d'électrode.
  8. Afficheur électroluminescent organique selon la revendication 7, dans lequel le circuit (320) de décharge électrostatique comprend en outre une seconde couche isolante (222) formée entre la couche semi-conductrice (229) et la première couche (223) d'électrode et/ou dans lequel le circuit (320) de décharge électrostatique comprend en outre une couche tampon (221) formée entre le substrat (210) et la couche semi-conductrice (229).
  9. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel le circuit (120) de décharge électrostatique comprend en outre une couche protectrice (126, 127) formée sur la deuxième couche d'électrode.
  10. Afficheur électroluminescent organique selon la revendication 9, dans lequel le circuit (120) de décharge électrostatique comprend en outre une troisième couche (128) d'électrode formée sur la couche protectrice (126, 127) et qui est raccordée électriquement à la deuxième couche (125) d'électrode par l'intermédiaire d'un trou traversant (v1).
  11. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel la zone (110b) sans pixels comprend en outre :
    - au moins un circuit d'attaque (130, 140, 150) constitué pour attaquer un pixel de la zone (110a) de pixels ; et
    - une plage de connexion (160) constituée pour raccorder électriquement le pixel et le circuit d'attaque avec un module externe.
  12. Afficheur électroluminescent organique selon la revendication 11, dans lequel la plage de connexion (160) est formée sur une partie interne d'au moins un côté du substrat (110).
  13. Afficheur électroluminescent organique selon la revendication 12, dans lequel le circuit (120) de décharge électrostatique est formé de façon à s'étendre le long d'au moins un côté du substrat (110) autre que le côté sur lequel est formée la plage de connexion (160).
  14. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel le circuit (320) de décharge électrostatique est formé séparément sur chaque côté de la périphérie interne du substrat (110).
  15. Afficheur électroluminescent organique selon l'une des revendications 1 à 13, dans lequel le circuit (120)

de décharge électrostatique est formé intégralement de façon à entourer pratiquement la périphérie interne du substrat (110).

16. Afficheur électroluminescent organique selon l'une des revendications 11 à 15, dans lequel l'une quelconque de la première couche (123) d'électrode et de la deuxième couche (125) d'électrode est raccordée électriquement à une plage de connexion (160) de la masse. 5  
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17. Afficheur électroluminescent organique selon l'une des revendications précédentes, dans lequel la première couche (123) d'électrode et la deuxième couche (125) d'électrode comprennent au moins l'un de l'aluminium, de l'aluminium-néodyme, du chrome, du molybdène, du molybdène-tungstène et du titane et/ou dans lequel la première couche isolante (124) comprend au moins l'un de l'oxyde de silicium, du nitrure de silicium et d'une matière organique. 15  
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FIG. 1

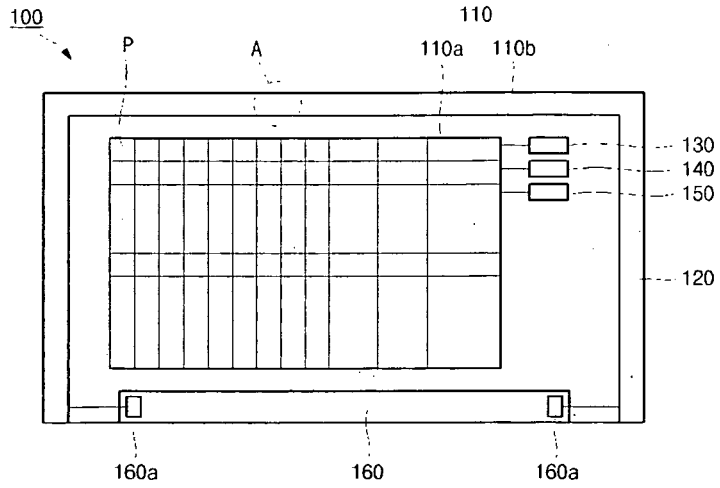


FIG. 2

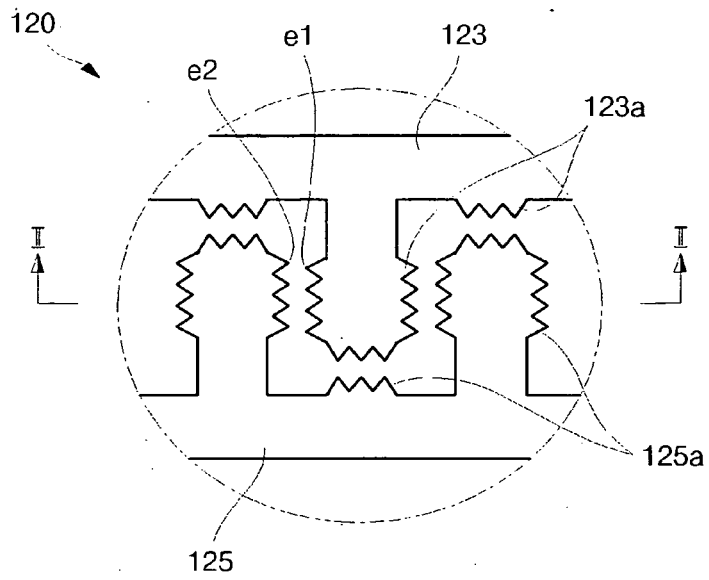


FIG. 3

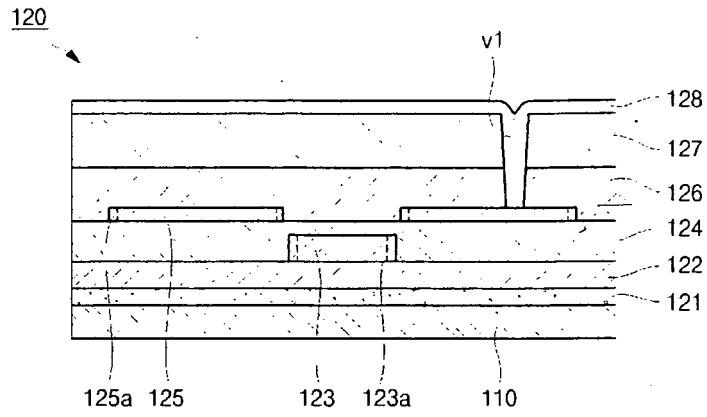


FIG. 4

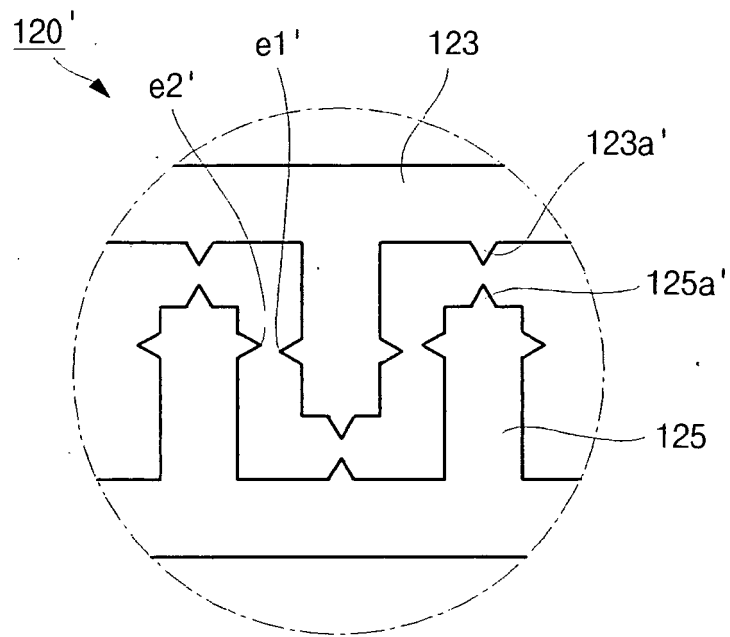


FIG. 5

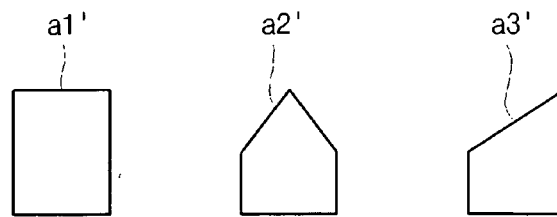


FIG. 6

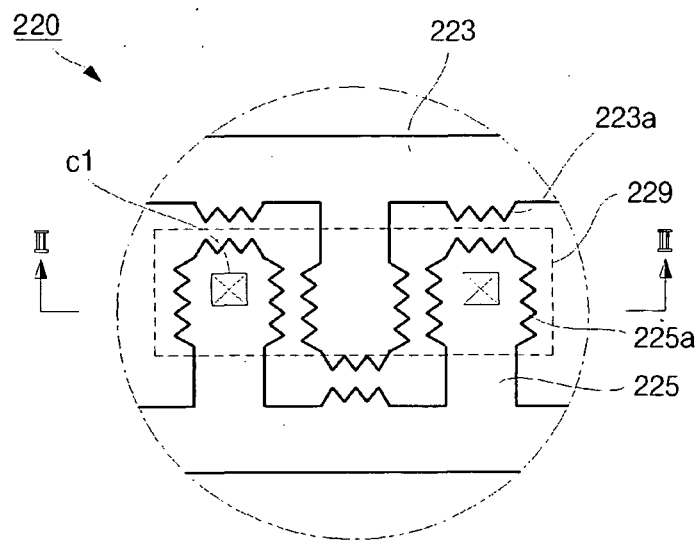


FIG. 7

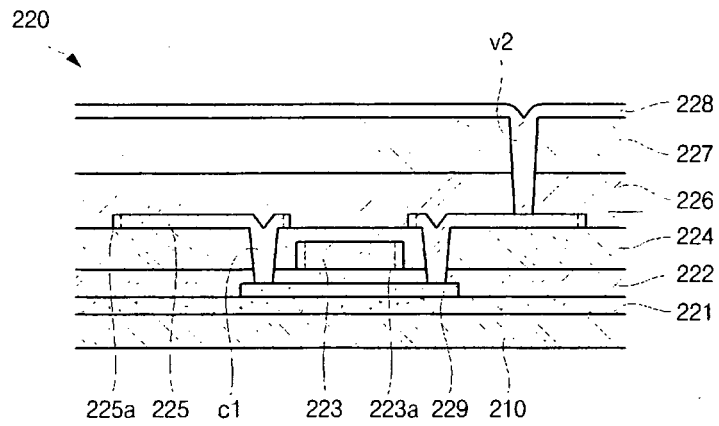
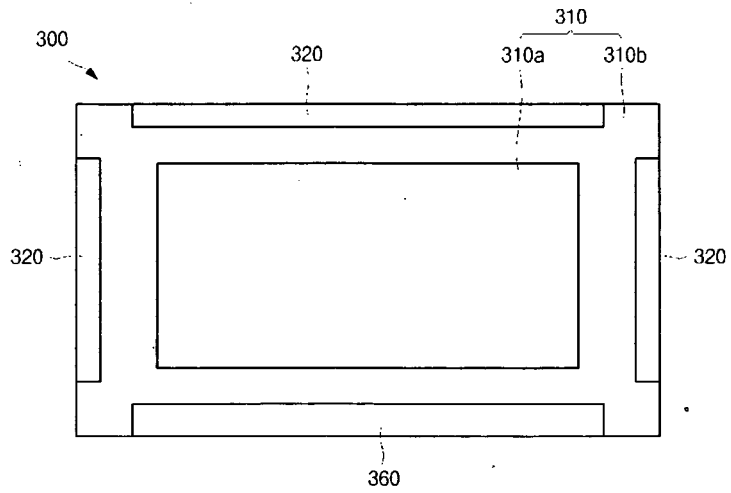


FIG. 8



**REFERENCES CITED IN THE DESCRIPTION**

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专利名称(译)	有机发光显示器具有静电放电电路		
公开(公告)号	<a href="#">EP1947697B1</a>	公开(公告)日	2013-12-25
申请号	EP2007119727	申请日	2007-10-31
[标]申请(专利权)人(译)	三星斯笛爱股份有限公司		
申请(专利权)人(译)	三星SDI CO. , LTD.		
当前申请(专利权)人(译)	三星DISPLAY CO. , LTD.		
[标]发明人	JEONG SEONI CHOI WOONGSIK		
发明人	JEONG, SEONI CHOI, WOONGSIK		
IPC分类号	H01L27/32 H01L27/02		
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代理机构(译)	hengelhaupt , Jürgen		
优先权	1020070006306 2007-01-19 KR		
其他公开文献	EP1947697A1		
外部链接	<a href="#">Espacenet</a>		

摘要(译)

公开了一种有机发光显示器，其中静电放电电路形成在基板的非像素区域上。静电放电电路包括第一电极层，形成在第一电极层上的第一绝缘层和形成在第一绝缘层上的第二电极层。第一电极层和第二电极层均包括突出电极，该突出电极形成朝向第一和第二电极层中的另一个水平延伸。根据有机发光显示器，通过使静电放电流通过突出电极消散，可以防止包括在有机发光显示器中的像素和驱动器被静电放电损坏。

